

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyoung-Ju SHIN et al.
Assignee: Samsung Electronics Co., Ltd.
Title: THIN FILM DIODE PANEL AND MANUFACTURING METHOD
OF THE SAME
Application No.: 10/578,028 Filing Date: April 27, 2006
Examiner: Thanh Nhan P. NGUYEN Group Art Unit: 2871
Docket No.: AB-1883 US Confirmation No.: 9578

Irvine, California
December 16, 2008

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated October 2, 2008, please amend the above-identified application as follows.

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